Nanocrystalline silicon oxide interlayer in monolithic perovskite/silicon heterojunction tandem solar cells with total current density >39 mA/cm²

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Abstract - Silicon heterojunction solar cells are implemented as bottom cells in monolithic perovskite/silicon tandem solar cells. Commonly they are processed with a smooth front side to facilitate wet processing of the lead-halide perovskite cell on top. The inherent drawback of this design, namely, enhanced reflection of the cell, can be significantly reduced by replacing the amorphous or nanocrystalline silicon front side n layer of the silicon cell by a nanocrystalline silicon oxide n layer. It is deposited with the same commonly used plasma-enhanced chemical vapor deposition and can be tuned to feature opto-electrical properties for enhanced light coupling into the Si bottom cell, namely, low parasitic absorption and an intermediate refractive index of ~2.6. We demonstrate that a 80 - 100 nm thick layer results in 0.9 mA/cm² current gain in the bottom cell yielding tandem cells with a top cell + bottom cell total current above 39 mA/cm². These first nc-SiO_x:H-coupled tandem cells reach an efficiency >23.5 %.

Index Terms — photovoltaic cells, silicon, heterojunctions, hybrid junctions.

I. INTRODUCTION

Silicon heterojunction (SHJ) solar cells are attractive for use as bottom cells in monolithic tandem cells with lead-halide perovskite top cells. This is because they have a high efficiency with an open circuit voltage above 730 mV combined with a high spectral response in the NIR regime. Moreover, from a processing point of view the device structure ideally matches the requirements for processing the perovskite top cell, namely, the top layer usually is a tin-doped indium oxide (ITO), which is a good substrate and contact material for the perovskite top cell. Due to the commonly used spin coating process for the perovskite top cell, it has to be deposited on a flat (polished) silicon wafer in order to obtain homogeneous cells without shunts. An early tandem cell reached an efficiency of 19.9 %, strongly limited by the bottom cell current [1]. Later a certified stable tandem efficiency of 23.6 % was presented [2] featuring better current matching. This cell, however, was still limited by the short circuit current of 18.1 mA/cm² and a total current (top + bottom) below 38 mA/cm². The limited total current was due to high reflection losses, partially as result of the flat interfaces.

To overcome the drawback of the flat front side, namely, light reflection out of the tandem cell at the interface between the perovskite (n @ 800 nm = 2.4) and the silicon (n @ 800nm =

3.7) sub cell, optical light coupling into the bottom cell by using an intermediate-refractive index material with low parasitic light absorption for wavelengths >700 nm is required. One option is plasma-enhanced chemical vapor deposited (PECVD) (doped) nanocrystalline silicon oxide (nc-SiO_x:H), which has been developed over the past years to replace the doped amorphous silicon contact layers in silicon heterojunction solar cells [3]. Due to its mixed-phase morphology with doped silicon (nano)crystals embedded in an amorphous silicon (sub)oxide matrix [4,5] its optical properties can be tuned over a wide range by varying the oxygen content, without deteriorating the electrical (contact) properties in the cell. We previously showed the superior properties in both-side textured rear p-type emitter SHJ solar cells featuring <10 nm thin n-type nc-SiO_x:H front contacts, namely, an enhanced short circuit current with excellent electrical properties ($\eta = 22.6\%$, $J_{sc} =$ 38.3 mA/cm^2 , $V_{oc} = 731 \text{ mV}$, FF = 80.6 %) [6]. Front-side flat cells of the same type and an optically adapted 17-nm thick nc-SiO_x:H but no ARC on the front TCO reached an efficiency of $\eta=20.4$ %, with $j_{sc}=35.7$ mA/cm², $V_{oc}=719$ mV, FF = 79.6 %. By adding a PECVD based SiO₂ AR layer on top of the TCO the cell current could be increased by 1.3 mA/cm² leading to 21.2 % cell efficiency.

In a recent paper we proposed the use of nc-SiO_x:H as an optical interlayer in perovskite / silicon tandem cells [7]. Optical simulations predicted ideal light coupling with nc-SiO_x:H having a refractive index (at 800 nm) of 2.6 and a thickness of 90 nm, which would facilitate a current matched tandem cell with $J_{sc} = 20.1 \text{ mA/cm}^2$, which is a high value for a SHJ cell with flat front interface and only the rear side being textured. Tandem cells with an efficiency up to 30 % are achievable and even higher values appear feasible with improved perovskite bandgap [7]. To validate this predicted high current, we realized tandem cells varying the interlayer refractive index and thickness as given in Table 1. We present the cell results.

II. EXPERIMENTAL DETAILS

The tandem device structure realized in the present study is depicted in Figure 1. Rear-emitter silicon heterojunction cells



Fig. 1. Left: Schematic cross section of the perovskite/silicon tandem solar cell processed in this study. <u>Right:</u> External quantum efficiency and 1 - total reflection of a tandem cell with nc-SiO_x:H interlayer (n @ 800 = 2.6, 100 nm) versus the reference cell with nc-Si:H.

were fabricated on 250-µm thick float-zone c-Si wafers. Singleside texturing of the rear side by KOH etching was done with a protecting a-SiO₂ cap on the polished front side. After cap removal and RCA cleaning of both sides, the silicon layer deposition was carried out in an Applied Materials PECVD cluster tool (AKT1600) applying an amorphous silicon i/p stack on the rear side and an i/n stack with (i) amorphous silicon and the (n) nc-SiO_x:H layer as the front contact. By varying the oxygen precursor gas (CO₂) flow we varied the oxygen content in the film, thereby tuning the refractive index at 800 nm in the range of 2.2 to 2.9. More details can be found elsewhere [8]. Finally, we sputtered 70 nm aluminum-doped zinc oxide (ZnO:Al) and 400 nm Ag as a rear reflector and contact stack. A 20-nm thick ITO layer was sputtered on the front. Both sputtering steps were done through masks defining 1.1 cm² cells on both sides of the wafer, with mask openings aligned to each other.

The perovskite top cell junction was fabricated on top of the front ITO cells by spin-coating a p-type poly-TPD doped with F4-TCNQ, followed by deposition of formamidinium, caesium, methylammopnium triple cation perovskite, $FA_{0.8}Cs_{0.5}MA_{0.5}Pb(I_xBr_{1-x})_3$ (where $x \sim 0.8$) using the antisolvent spin-coating method. The perovskite films were cured at 100°C for 30 minutes. The devices were completed with n-side contact, window TCO and evaporated gold grid at Oxford PV.

Light IV measurements were performed using a Keithley model 2600 digital source meter and OAI trisol solar simulator. Characteristics were measured using both reverse-forward and forward-reverse bias voltage sweeps, as well as a perturb-andmeasure maximum power tracking algorithm to confirm stabilised power output. External quantum efficiency (EQE) was recorded for each respective subcell using a Bentham PVE300 setup. For optical simulations n & k parameters of all materials were determined from single layers deposited on glass. The generated current was calculated from the carriers generated in the perovskite and c-Si absorbers, respectively, assuming 100% carrier collection efficiency.

III. RESULTS AND DISCUSSION

We studied SHJ cells with an n-type nc-SiO_x:H intermediate layer varying the refractive index (at 800 nm) between 2.2 and 2.9 by changing the oxygen content and changing the thickness between 20 and 100 nm. The resulting current densities derived from EQE are compared to the simulated current densities. For reference a 12-nm thick nc-Si:H n layer (without oxygen), which is the standard n layer for our SHJ cells, was used. As an example, Figure 1 shows the EQE curve of a tandem cell with an intermediate layer, as compared to the reference. It can be seen that due to suppressed reflection losses in the range of 750 - 1000 nm the bottom cell gains 0.9 mA/cm² at almost constant top cell current.

One of the best cells of this study reached an efficiency of 23.5 % (V_{oc} = 1.70 V, FF = 76.4 %, cf. Fig. 2) even though it is still strongly limited by the bottom-cell current due to the high top cell current and current mismatch. This result shows a clear path to improve the tandem efficiency by minor increase in top cell bandgap (via changes in perovskite composition) that can deliver tandem current matching at >19.5 mA/cm². Table 1 and Figure 3 show experimental and simulated results demonstrating the trend as was generally predicted from simulations [7]. An optimum nc-SiO_x:H refractive index of 2.6 -2.9 is found. With increasing thickness the bottom cell current is raised, saturating around 80 - 100 nm thickness. This trend is driven by the reduced reflection out of the cell, due to better light coupling into the bottom cell. The gain is on the order of 1 mA/cm² in the experiments and slightly higher in the

simulations. The top cell current is unaffected. A total current density (top cell + bottom cell) as high as 39.3 mA/cm^2 is obtained for the optimized configuration.

IV. CONCLUSIONS AND OUTLOOK

We demonstrated by means of experiments and simulations that the incorporation of an optimized n-type nc-SiO_x:H interlayer in perovskite/silicon heterojunction tandem cells between the top and bottom cell leads to an increase of the bottom-cell current density by 1 mA/cm². With the best cells shown here having 23.5% efficiency and further adjustment to match both cells' currents a rapid further improvement to reach a device efficiency to >25% by using a wider band gap perovskite seems very feasible.

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Fig. 2. Light IV curve of a 23.5 % perovskite/SHJ tandem cell with a 80-nm thick nc-SiO_x:H interlayer with $n_{nc-SiOx:H}(800 \text{ nm}) = 2.6$.



Fig. 3. Experimental and simulated current density for top and bottom cell and reflection as a function of the nc-SiO_x:H interlayer thickness, for $n_{nc-SiO_x}(800 \text{ nm}) = 2.6$.

TABLE I

PHOTO CURRENTS DETERMINED FROM EQE AND REFLECTION MEASUREMENTS AND EQUIVALENT PHOTO CURRENTS FROM OPTICAL SIMULATIONS, ASSUMING 100% CARRIER COLLECTION EFFICIENCY FOR CHARGES GENERATED IN THE PEROVSKITE AND SILICON ABSORBER LAYERS.

nc-SiO _x :H		Top cell		Bottom cell		R_tot	
Thickn.	n	Exp.	Sim.	Exp.	Sim.	Exp.	Sim.
nm	-	Integrated values (300-1200 nm) in mA/cm ²					
0	-	21.1	21.3	17.4	17.1	3.9	4.0
20	2.6	-	21.3	-	16.9	-	4.1
50	2.6	21.0	21.2	17.7	17.5	4.4	3.6
80	2.6	21.3	21.2	18.4	18.4	3.6	2.7
100	2.6	21.0	21.2	18.3	18.6	3.0	2.4
50	2.9	21.0	21.2	17.9	17.7	3.8	3.4
50	2.2	21.1	21.3	16.6	16.7	5.2	4.3

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